



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Kikuchi et al.

Application No. 10/635,661

Filed: August 5, 2003

Confirmation No. 8882

For: RETICLE MANIPULATORS AND  
RELATED METHODS FOR CONVEYING  
THIN, CIRCULAR RETICLES AS USED  
IN CHARGED-PARTICLE-BEAM  
MICROLITHOGRAPHY

Examiner: Della J. Rutledge

Art Unit: 2851

Attorney Reference No. 4641-65956-01

CERTIFICATE OF MAILING

I hereby certify that this paper and the documents referred to as being attached or enclosed herewith are being deposited with the United States Postal Service as First Class Mail in an envelope addressed to: MAIL STOP AMENDMENT COMMISSIONER FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450 on the date shown below.

Attorney  
for Applicant(s) Donald L. Styberg

Date Mailed January 21, 2005

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COMMISSIONER FOR PATENTS  
P.O. BOX 1450  
ALEXANDRIA, VA 22313-1450

**AMENDMENT AND REPLY TO OFFICE ACTION**

This paper is submitted in reply to the Office action dated October 5, 2004. Please amend the subject application as follows:

**Amendments to the Abstract** begin on page 2.

**Amendments to the Specification** begin on page 3.

**Amendments to the Drawings** begin on page 4.

**Remarks** begin on page 5.